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TO: Examiner Quovaunda Jefferson
ART UNIT 2823

FAX NO.: (571)-273-8300

FROM: Jeff Lloyd

DATE: December 5, 2006

NO. OF PAGES (INCLUDING COVER SHEET): 10

SUBJECT/MESSAGE:

Re: U.S. Patent Application Serial No. 10/757,821; filed January 15, 2004
METHOD OF MAKING A MONITORING PATTERN TO MEASURE A DEPTH AND A PROFILE
OF A SHALLOW TRENCH ISOLATION
(Kang)
Attorney Docket No. SUN-DA-1381

Attachments:

1. Amendment Under 37 CFR §1.111 (4 page)
2. Information Disclosure Statement (2 pages)
3. Form PTO/SB/08 (1 page)

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5 DECEMBER 2006
Jeff Lloyd, Patent Attorney, Reg. No. 35,589

AMENDMENT UNDER 37 C.F.R. § 1.116
Examining Group 2823
Patent Application
Docket No. SUN-DA-138T
Serial No. 10/757,821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : Quovamda Jefferson
Art Unit : 2823
Applicant : Jung Ho Kang
Serial No. : 10/757,821
Filed : January 15, 2004
Confirm. No. : 5400
For : A Method of Making a Monitoring Pattern to Measure a Depth and a Profile
of a Shallow Trench Isolation

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Office Action dated October 5, 2006, please amend the application referred
to above as follows: